

A METHOD FOR DECREASING CHC DEGRADATION

ABSTRACT OF THE DISCLOSURE

A method for decreasing CHC degradation is provided.

5 The method includes providing a semiconductor device (10) having at least one metal layer (28) completed. Then, a planarizing dielectric layer (30) is added to the semiconductor device (10). The semiconductor device (10) is heated in a hydrogen rich environment until hydrogen
10 completely saturates the semiconductor device (10).

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